

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : James S. Im  
Serial No. : 10/524,809 Examiner : Toledo, Fernando L.  
Filed : February 15, 2005 Group Art Unit: 2895  
For : **SINGLE-SHOT SEMICONDUCTOR PROCESSING SYSTEM AND  
METHOD HAVING VARIOUS IRRADIATION PATTERNS**

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the outstanding Official Action mailed September 17, 2008, Applicant submits this response and requests a two month extension of time.

**Amendment to the Claims** reflected in a complete listing of the claims begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.